

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Kazuaki OHMI et al.

Serial No.: *To be assigned*                      Group Art Unit: *To be assigned*

Filed: June 25, 2003                      Examiner: *To be assigned*

For: SEPARATING APPARATUS, SEPARATING METHOD, AND  
METHOD OF MANUFACTURING SEMICONDUCTOR  
SUBSTRATE

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination on the merits, please enter this Preliminary Amendment in the above-referenced application.

**IN THE SPECIFICATION:**

**On page 1, line 6, please insert the following paragraph:**

**CROSS-REFERENCE TO RELATED APPLICATION**

This is a divisional application under 37 C.F.R. §1.53(b) of copending US Patent Application Serial Number 09/495,847, filed on February 1, 2000, which is incorporated herein by reference in its entirety.

**IN THE CLAIMS:**

**Please cancel claims 1-19 without prejudice or disclaimer.**